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**Box Patent Application**  
**Assistant Commissioner for Patents**  
**Washington, D.C. 20231**

New U.S. Patent Application

Title: PLASMA PROCESSING APPARATUS AND PLASMA  
PROCESSING METHOD

Inventors: Chishio KOSHIMIZU and Kazunori NAGAHATA

Sir:

We enclose the following papers for filing in the United States Patent and  
Trademark Office in connection with the above patent application.

1. A check for \$844 representing a \$804 filing fee and \$40 for recording the Assignment.
2. Application - 27 pages, including 4 independent claims and 22 claims total.
3. Drawings - 5 sheets of formal drawings containing 5 figures.
4. Declaration and Power of Attorney.
5. Recordation Form Cover Sheet and Assignment to Tokyo Electron Limited.
6. Certified copy of Japanese Patent Application No. 11-268578, filed September 22, 1999.

Applicants claim the right to priority based on Japanese Patent Application No.  
11-268578, filed September 22, 1999.

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Please accord this application a serial number and filing date and record and return the Assignment to the undersigned.

The Commissioner is hereby authorized to charge any additional filing fees due and any other fees due under 37 C.F.R. § 1.16 or § 1.17 during the pendency of this application to our Deposit Account No. 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,  
GARRETT & DUNNER, L.L.P.

By: David W. Hill  
David W. Hill  
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DWH/FPD/dvz  
Enclosures

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